



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yasunori Ito, et al.
Serial No.: 10/640,850
Filed: August 13, 2003
For: METHOD OF PRODUCING
CERAMIC THERMISTOR
CHIPS
Group Art Unit: 1742
Examiner: H. D. Wilkins III
Attorney Docket: MURTP083D1

CERTIFICATE OF MAILING

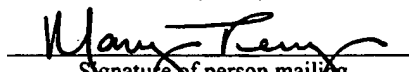
Date of Deposit: November 19, 2007

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AMENDMENT "F" AFTER FINAL ACTION

Mail Box: AF
Commissioner for Patents
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*Do Not Enter
Larry Wilkins*

Sir:

In response to the Final Office Action dated September 20, 2007 in the above-
referenced application, applicant amends the application as follows: